Enhanced Electrodiffraction and Electrochromism from Electrodeposited ZnO-WO3 and ZnO-PEDOT Gratings

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KEYWORDS electrodeposition, electrochemically modulated diffraction, tungsten oxide, PEDOT, zinc oxide, nanostructured surfaces

Abstract

Enhanced electrochromic and electrodiffractive properties were observed from a novel twocomponent composite nanostructured electrodeposited grating that incorporated both an electrochromic material (either tungsten oxide (WO₃) or poly(3,4-ethylenedioxythiophene) (PEDOT)) and zinc oxide (ZnO), a high refractive index material. The sequential electrodeposition of these two materials through a photopatterned photoresist layer onto a fluorine-doped tin oxide (FTO) coated glass substrate created a grating structure that exhibited optical diffraction that could be modulated electrochemically. SEM images of the electrochromic gratings revealed that the ZnO electrodeposition created a high surface area nanostructured thin film. The nanostructured ZnO is non-absorbing, but acts as an antenna to redirect light into the electrochromic grating and create a four-fold enhancement in the grating's electrodiffractive response.

Introduction

Optical diffraction gratings that split, redirect, and disperse light are fundamental optical elements that have been incorporated into a myriad of optical devices including laser barcode scanners, optical switches, and spectrometers.¹⁻⁹ While the most common implementation of optical diffraction gratings is a periodic metallic or semiconductor surface structure, any surface or thin film material with an optical response that varies periodically on the order of the wavelength of light will exhibit optical diffraction. If we define the linear optical response in terms of the complex refractive index $n = \eta + i\kappa$, then periodic variations in κ are typically called absorptive gratings, while periodic variations in η are described as phase gratings.¹⁰⁻¹⁶

Electrochromic thin films are a unique class of materials with a complex refractive index that can be varied reversibly by either oxidation or reduction reactions induced by changes in an applied potential in an electrochemical cell. The electrochromism of these thin films specifically refers to the electrochemically induced color changes. Electrochromic thin films demonstrate a potential dependence of κ , the imaginary part of the complex refractive index; however, changes in η , the real part of the complex refractive index, can also occur. Two of the most well-studied electrodeposited electrochromic thin film materials are tungsten oxide (WO₃)¹⁷⁻²⁰ and poly(3,4ethylenedioxythiophene) (PEDOT).²¹⁻²⁵ Typical potential dependent variations of κ for these two materials are ±0.09 and ±0.07, respectively, in the visible region at 600 nm.²⁶⁻²⁷

Due to the potential dependence of η and κ for electrochromic thin films, diffraction gratings that are fabricated from these materials also exhibit a diffraction efficiency that varies with applied potential. This effect has been observed previously and has been denoted as either "electrochemically modulated diffraction"^{15, 28-30} or "electrotunable diffraction",³¹⁻³² but in this

paper, we will denote this phenomenon simply as "electrodiffraction" as compared to electrochromism.

In this article, we have observed and quantitated the enhancement of electrodiffraction from a novel two-component composite nanostructured diffraction grating that incorporates both an electrochromic material (either WO₃ or PEDOT) and a nanostructured high refractive index material (ZnO, $\eta = 1.998$ at 633 nm). These composite gratings are fabricated by a two-step electrodeposition process on a fluorine-doped tin oxide (FTO) coated glass substrate as depicted schematically in Figure 1. A pattern of 10 µm wide lines of either WO₃ or PEDOT separated by 5 µm of glass is created by electrodeposition onto an FTO glass substrate that is partially protected with a photopatterned film of photoresist. This initial electrochromic grating pattern has a film thickness of about 200 nm. A second electrodeposition step creates a nanostructured ZnO film on top of the electrochromic grating, with a film thickness of typically 600 nm. We show that this non-absorbing nanostructured ZnO film enhances both the optical absorption and the electrodiffraction from this grating; it acts as an antenna for the electrochromic material and results in a four-fold increase of the electrodiffractive response.

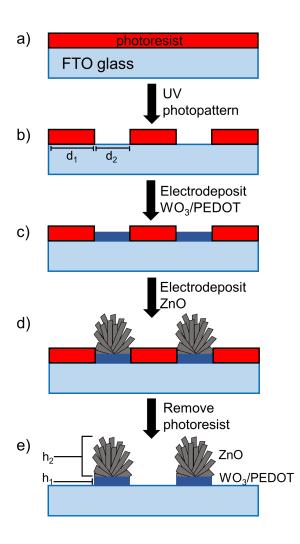


Figure 1. Schematic of the fabrication process of ZnO-WO₃ and ZnO-PEDOT gratings.

Experimental Considerations

Fabrication of WO₃ gratings. FTO coated glass slides (~30 Ω /sq cm, Sigma-Aldrich) were cleaned by ultrasonication in an aqueous Hellmanex (1%) solution, rinsed with water and ethanol, and dried under an N₂ stream. The FTO coated glass slides were then plasma cleaned under O₂ plasma for 2 min. S1808 positive photoresist was spincoated at 2500 rpm for 80 s onto the glass slides, baked at 90°C for 25 min to evaporate photoresist solvent, and cooled to room temperature. The photoresist coated glass slides were exposed to a UV lamp source (50 W, Oriel

Instruments He(Xe) arc lamp) for 3.5 s and patterned using a photomask with 5 μ m wide Cr lines and 10 μ m glass spacings. The photoresist was then developed for 25 s using MF-319 developer (Microchem), rinsed with nanopure water, and dried under an N₂ stream. An electrical contact area was made by dissolving the corner of the photoresist with acetone using a Q-tip. WO₃ was then electrochemically deposited onto the photopatterned FTO substrate using a potentiostat (PGSTAT12, Metrohm Autolab) in a three-electrode setup. The working electrode of the photopatterned FTO substrate was exposed to an aqueous peroxytungstatic acid (H₂W₂O₁₁) plating solution for 150 s at a cathodic potential of -0.5 V vs. a Ag/AgCl reference electrode in the presence of a Pt counter electrode.

Fabrication of PEDOT gratings. FTO glass slides (~ 30Ω /sq cm, Sigma-Aldrich) were degreased by sonication in deionized water, acetone, and methanol, and then dried with a nitrogen jet. Poly(3,4-ethylenedioxythiophene)-poly(styrenesulfonate) (PEDOT:PSS, 2.0 wt. % in H₂O, Sigma-Aldrich) was mixed with isopropyl alcohol and ethylene glycol (ratio 85:10:5) to enhance electronic conductivity and improve wetting. A thin PEDOT:PSS layer was spincoated onto the FTO glass substrate at 3000 rpm for 20 s. Positive photoresist (S1808, Microchem) was then spincoated at 2500 rpm for 80 s onto the FTO glass substrate, and baked at 90°C for 25 min to evaporate the photoresist solvent. After cooling down to room temperature, the photomask with 5 µm wide Cr lines and 10 µm glass spacings was placed flushed onto the substrate. The photoresist was exposed through the photomask using a UV lamp source (50 W, Oriel Instruments He(Xe) arc lamp) for 3.5 s. The photoresist was patterned and developed with MF-319 developer, rinsed with nanopure water, and dried under a N₂ stream. An electrical contact area was made by dissolving the corner of the photoresist with acetone using a Q-tip. The PEDOT electrodeposition was performed with a potentiostat (PGSTAT12, Metrohm Autolab),

where the FTO glass substrate was exposed to an aqueous electrolyte consisted with 0.02 M 3,4ethylenedioxythiophene (EDOT, 97%, Sigma-Aldrich), 0.1 M sodium dodecyl sulfate (SDS) and 0.1 M lithium perchlorate (LiClO₄, 99.5%, Alfa), at a constant potential of +1.0 V vs. a Ag/AgCl reference electrode for 150 s in the presence of a Pt counter electrode.

Fabrication of nanostructured ZnO gratings. The electrodeposition of nanostructured ZnO was performed with a potentiostat (PGSTAT12, Metrohm Autolab) using a three-electrode setup. An aqueous solution containing 0.1 M Zn(NO₃)₂•6H₂O (98%, Sigma-Aldrich) and 0.1 M KCl heated to 70°C was used as the plating solution. The working electrode of either a WO₃ or PEDOT grating array surface was exposed to the plating solution for 600 s at a constant potential of -0.9 V vs. a Ag/AgCl reference electrode and in the presence of a Pt counter electrode to form a nanostructured ZnO film over the WO₃ or PEDOT gratings. Finally, the sample was rinsed with acetone to remove remaining photoresist, and dried under a N₂ stream.

Morphological characterization. SEM images were obtained using a FEI Magellan 400 fieldemission scanning electron microscope at an accelerating voltage of 5 kV. AFM measurements were collected using an Asylum Research MFP-3D, and AFM images were analyzed using Gwyddion imaging processing software. For UV-Vis/NIR absorbance measurements, a Jasco V-670 UV-Vis/NIR spectrophotometer was used. To measure *ex situ* absorbance spectra, a potential of -1.0 V vs. Ag/AgCl was applied to the grating surfaces for 15 s in a 0.1 M LiClO₄ in polycarbonate solution before removing the grating surfaces from solution for spectroscopic analysis.

Optical diffraction analysis. For diffraction and transmittance measurements, the grating surface was placed in an electrochemical cell connected to a potentiostat (Palmsens3, Palmsens) in a three-electrode setup. The grating sample was placed in a 0.1 M LiClO₄ in polycarbonate

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solution under alternating step potentials of -1.0 V and +1.0 V (15 s at each potential for a total duration of 250 s) vs. a Ag/AgCl reference electrode and in the presence of a Pt counter electrode. Light from a HeNe laser ($\lambda = 633$ nm, 12 mW, LHRP-1201, Research Electro-Optics), *p*-polarized using a polarizer (Newport), was emitted and chopped at a frequency of 1.0 kHz using an optical chopper (Stanford Research Instruments SR540). A transmission geometry was employed in these optical measurements, where the intensities of the diffracted light (at the *n* = 1 spot) and transmitted light (at the *n* = 0 spot) were measured by a photodiode (Hamamatsu) connected to a DSP lock-in amplifier (EG&G model 7220). The photodiode potentials were recorded by a Labview program. For %T measurements at the *n* = 0 spot, a FTO glass substrate was used as reference. For %DE measurements, the photodiode intensities at the *n* = 1 spot were divided by the photodiode intensity at the *n* = 0 spot at +1.0 V vs. Ag/AgCl (when the grating is at its most transmissive state).

Results and Discussion

a) Electrodeposition and Characterization of ZnO-WO₃ and ZnO-PEDOT Gratings.

WO₃ electrodeposition. The mechanism of WO₃ electrodeposition from acidic peroxytungstatic acid (H₂W₂O₁₁) solutions has been described previously by other researchers.³³⁻³⁴ Electrodeposition occurred at negative potentials (-0.4 V vs. Ag/AgCl) through a combination of electrochemical reduction and disproportionation of the four peroxide (O₂²⁻) anions in the peroxytungstate ions as described in Equation 1, where *x* is either 0, 4 or 8:

$$W_2O_{11}^{2-} + (2+x) H^+ + xe^- \rightarrow 2WO_3 + \frac{(2+x)}{2}H_2O + \frac{(8-x)}{4}O_2$$
 (1)

If x = 8, then all four of the peroxide anions are reduced electrochemically to three O²⁻ ions (in the electrodeposited WO₃) and five H₂O. If x = 0, then the four peroxide anions disproportionate to form three O²⁻ ions, H₂O and two O₂. In addition to the peroxide reduction, a non-stoichiometric amount of W⁶⁺ ions in the WO₃ are also reduced to W⁵⁺:

$$zH^+ + WO_3 + ze^- \rightarrow H_zWO_3$$
 (2)

This tungsten reduction is verified by the observation of a blue color of the electrodeposited WO₃ film.

PEDOT electrodeposition. A PEDOT thin film was formed by the electrodeposition of 3,4ethylenedioxythiophene (EDOT) using a slightly modified procedure of a previously reported method.³⁵⁻³⁸ In order to create stable PEDOT films, a thin layer of PEDOT:PSS was first spincoated onto the FTO glass substrate to enhance conductivity and improve wetting of the surface, then a thicker layer of PEDOT was formed by the electropolymerization of EDOT. In an aqueous plating solution consisting of 0.02 M EDOT, 0.1 M SDS and 0.1 M LiClO₄, a constant potential of +1.0 V vs. Ag/AgCl was applied for 150 s to a photopatterned FTO glass substrate in the presence of a Pt counter electrode. The electrodeposited film is in the reduced state, as evidenced by its blue color.

ZnO electrodeposition. Nanostructured ZnO was also selectively deposited electrochemically on top of the WO₃ or PEDOT thin film. In our approach, 0.1 M aqueous zinc nitrate at pH 4.0 heated to 70°C was used as the plating solution, and electrodeposition occurred for 600 s at a potential of -0.9 V vs.Ag/AgCl. The mechanism of the ZnO electrodeposition process has been discussed in previous works,³⁹⁻⁴¹ and is summarized as follows: At a sufficiently negative applied potential, NO₃⁻ ions are reduced to generate OH⁻ ions (eqn (4)). The OH⁻ and the Zn²⁺ ions then result in the precipitation of ZnO onto the working electrode of either WO₃ or PEDOT gratings (eqn (5)).

$$NO_3^- + H_2O + 2e^- \rightarrow NO_2^- + 2OH^-$$
(4)

$$Zn^{2+} + 2OH^{-} \rightarrow ZnO \downarrow + H_2O \tag{5}$$

Grating fabrication. The ZnO-WO₃ and ZnO-PEDOT gratings were fabricated using a combination of photolithography and electrodeposition. As shown in the scheme in Figure 1, after a layer of photoresist was spincoated onto conductive FTO glass slides, UV photopatterning was employed to create an array of photoresist stripes of width $d_1 = 5 \mu m$ that were separated by 10 μm spacings of glass substrate. WO₃ or PEDOT was then selectively deposited electrochemically onto the exposed glass to form arrays of continuous micron-scale stripes of width $d_2 = 10 \mu m$. After the electrodeposition of both the electrochromic and ZnO layers, the photoresist was removed using acetone to create a diffraction grating surface that consists of an array of 10 μm wide ZnO-WO₃ or ZnO-PEDOT stripes separated by 5 μm wide spacings. The morphology of the ZnO-WO₃ and ZnO-PEDOT diffraction gratings was characterized using a combination of SEM, AFM, and XPS. SEM images in Figure 2 shows a) ZnO-WO₃ gratings and

b) ZnO-PEDOT gratings that are composed of an array of 10 µm wide stripes that extend continuously over a length of several microns with 5 µm spacings in between. It should also be noted that the lower contrast in Figure 2b compared to 2a is due to the presence of a thin layer of PEDOT:PSS in the 5 µm spacings between the ZnO-PEDOT stripes in the ZnO-PEDOT gratings (since a thin layer of PEDOT:PSS was spincoated onto the FTO glass substrate to ensure stable electropolymerized PEDOT thin films), whereas the ZnO-WO₃ stripes are separated by 5 µm spacings of glass substrates in the ZnO-WO₃ gratings. The insets of the SEM images show highresolution images of the nanostructured ZnO, where the individual flake-like ZnO nanostructures on the surface are depicted. This is a contrast to the mostly planar and featureless morphology of the WO₃ or PEDOT gratings before the addition of the ZnO layer, as confirmed by SEM images in Supporting Information Figure S1. In addition, AFM measurements (see Supporting Information Figure S2) reveal that an electrochromic layer of height $h_1 = 200$ nm was formed, and a nanostructured ZnO layer of height $h_2 = 600$ nm was formed. Finally, XPS measurements confirmed the formation of ZnO over both the WO₃ and PEDOT grating surfaces (Supporting Information Figure S3).

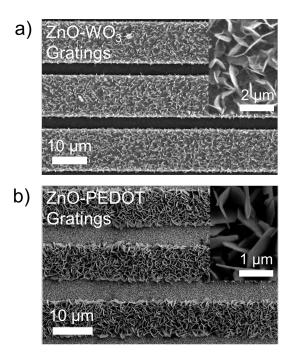


Figure 2. SEM images of a set of a) ZnO-WO₃ and b) ZnO-PEDOT gratings. The insets show high-resolution images of the nanostructured ZnO overlayer decorating the gratings.

b) Absorbance Spectra of ZnO-WO₃ and ZnO-PEDOT Gratings.

The absorbance spectra of the composite gratings were measured using a normal incidence transmission geometry, and it was revealed that the addition of a nanostructured ZnO overlayer on both the WO₃ and PEDOT gratings resulted in enhanced light absorption capabilities. The UV-Vis/NIR absorbance spectra for an electrodeposited WO₃ thin film (blue curve), an electrodeposited WO₃ grating (red curve) and an electrodeposited composite ZnO-WO₃ grating (black curve) are all shown in Figure 3a. These three *ex situ* spectra were obtained from samples that were first held at an applied potential of -1.0 V vs. Ag/AgCl for 30 s in an electrochemical cell containing a 0.1 M LiClO₄ solution, then removed for spectroscopic measurements. As seen in Figure 3a, there is a strong absorbance peak around 1000 nm for the both the planar WO₃ thin films and the WO₃ gratings. Photographs of these two surfaces are also

shown in Figure 3a and both exhibit the well-known blue color associated with reduced WO₃ electrochromic films. The spectrum of the WO₃ grating shows a slightly stronger absorption band than the planar thin film, and thus the color of the WO₃ grating is a darker blue.

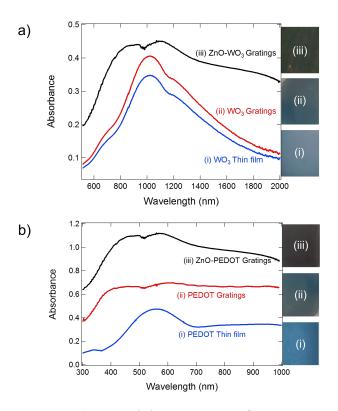


Figure 3. a) UV-Vis/NIR spectra of ZnO-WO₃ gratings, WO₃ gratings, and WO₃ thin film. b) UV-Vis/NIR spectra of ZnO-PEDOT gratings, PEDOT gratings, and PEDOT thin film. Photographs of each sample are also shown.

In contrast, the spectrum of the ZnO-WO₃ grating shows significantly enhanced absorbance at all wavelengths from 500 nm to 2000 nm. The addition of the nanostructured ZnO overlayer must enhance the light absorption capabilities of the WO₃ grating underneath, since the electrodeposited ZnO has a high refractive index but no absorptive component ($\kappa = 0$). The UV-Vis/NIR absorbance spectrum of ZnO does not exhibit any absorption bands from 500 nm to 2000 nm, due to its high bandgap of 3.3 eV (375 nm).⁴² Nevertheless, the addition of ZnO to

form the ZnO-WO₃ gratings significantly enhances the optical absorption of the WO₃ gratings. The enhanced absorption also results in changes in visual appearance of the ZnO-WO₃ gratings, which becomes black as shown in Figure 3a. This data clearly shows that there is a significant amount of light coupled or redirected from the nanostructured ZnO overlayer to the underlying WO₃ portion of the grating structure.

A similar effect was observed for ZnO-PEDOT gratings. The UV-Vis/NIR absorbance spectra of an electrodeposited planar PEDOT thin film, an electrodeposited PEDOT grating, and an electrodeposited ZnO-PEDOT grating are shown in Figure 3b. It has been shown previously that PEDOT thin films exhibit a π to π^* transition with a bad gap of 1.7 eV (775 nm), thus PEDOT thin films in the reduced state show significant optical absorption near 600 nm,^{24-25, 43} as evidenced by the blue trace in Figure 3b. Similar to the WO₃, PEDOT films also have a characteristic blue color in the reduced state as seen in the inset to Figure 3b. The PEDOT grating adds an additional absorption band at 450 nm (see Figure 3b) that has been attributed to an interference effect of the PEDOT grating, and is a darker blue in color as seen in the Figure 3b inset. As in the case of the ZnO-WO₃ gratings, the ZnO-PEDOT gratings also show a broadband enhancement in the UV-Vis/NIR absorbance spectrum, and has a black visual appearance, also seen in the inset of Figure 3b. We attribute this enhanced absorption from of ZnO-PEDOT gratings to the same mechanism as in the of ZnO-WO₃ gratings: coupling or redirection of light from the nanostructured ZnO overlayer to the underlying PEDOT grating.

c) Electrodiffraction of ZnO-WO₃ and ZnO-PEDOT Gratings.

While the nanostructured ZnO overlayer enhances the absorptive properties of WO₃ and PEDOT gratings, there is an even larger effect on the electrochemically modulated diffraction. Electrodiffraction from electrodeposited ZnO-WO₃ and ZnO-PEDOT gratings at λ = 633 nm was measured *in situ* at normal incidence in an electrochemical cell containing 0.1 M LiClO₄ in polycarbonate, as shown schematically in Figure 4a. A representative diffraction pattern is shown in Figure 4b.

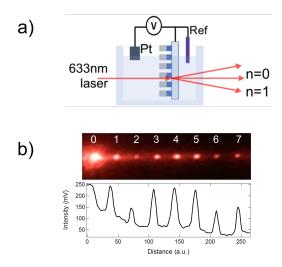


Figure 4. a) Schematic of the setup used for electrochemically modulated optical measurements of ZnO-WO₃ and ZnO-PEDOT gratings. b) Photograph of and intensity profile of diffraction pattern created by a set of ZnO-WO₃ gratings.

To measure the electrodiffractive response, the applied potential to a ZnO-WO₃ or ZnO-PEDOT grating was stepped between -1.0 V to +1.0 V vs. Ag/AgCl every 15 seconds. The current transients from the potential steps are shown in Figure 5. The current transients are higher for the ZnO-WO₃ grating as compared to the WO₃ grating, as shown in Figure 5b; we attribute this to the larger charging currents for high surface area nanostructured ZnO. Similar trends were observed for the ZnO-PEDOT and PEDOT gratings in Figure 5c.

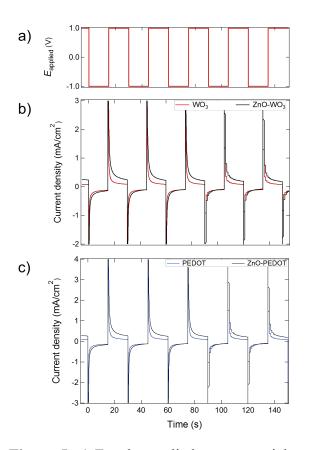


Figure 5. a) For the applied step potentials of -1.0 V and +1.0 V vs. Ag/AgCl, corresponding current transients for b) ZnO-WO₃ and WO₃ gratings, as well as c) ZnO-PEDOT and PEDOT gratings are shown.

The electrochemically modulated optical signals for transmission (n = 0) and first order diffraction (n = 1) were acquired as a function of time from both ZnO-WO₃ gratings (Figures 6b and 6c) and ZnO-PEDOT gratings (Figures 7b and 7c). The %T observed in Figure 6b from the n= 0 spot for both WO₃ gratings and ZnO-WO₃ gratings varied reversibly with applied potential due to the electrochromic properties of WO₃. For the WO₃ grating, %T alternated between 79% at +1.0 V to 27% at -1.0 V (potentials measured against Ag/AgCl). At -1.0 V, Li ion intercalation and electron injection into the WO₃ grating lead to an increase in κ and the large increase (Δ %T = 52%) in light absorption. This effect has been observed previously, on both planar WO₃ films and gratings.¹⁷⁻¹⁹ Similar electrochromic effects were observed for the ZnO-WO₃ gratings, with a $\Delta\%$ T = 46%. However, the average intensity of the transmitted light was lower for the ZnO-WO₃ gratings as compared to undecorated WO₃ gratings (T_{ave} = 40% vs T_{ave} = 55%). This decrease is expected from the absorption spectra results discussed in the previous section.

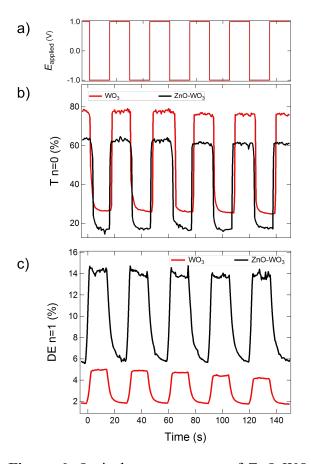


Figure 6. Optical measurements of ZnO-WO₃ and WO₃ gratings after a) applied potentials of -1.0 V and +1.0 V vs. Ag/AgCl showing the b) transmittance at the n = 0 spot and the c) diffraction efficiency at the n = 1 spot.

In contrast to the electrochromic behavior, both the average and the electrochemically modulated diffraction efficiency (%DE) observed for the n = 1 diffraction spot were greater for the ZnO-WO₃ gratings compared to the WO₃ gratings. As seen in Figure 5c, the electrochemical modulation of %DE was 180° out of phase with the modulation of %T, i.e., the more absorptive state, -1.0 V vs. Ag/AgCl, saw a low %T but a high %DE, and vice versa at +1.0 V vs. Ag/AgCl. An average %DE of 3.2% and an electrochemically modulated Δ %DE of 2.4% were observed for WO₃ gratings (red trace in Figure 5c). For the ZnO-WO₃ gratings, the average %DE increased to 10%, and the electrodiffraction increased to a Δ %DE of 9.7% – four times higher than the gratings without ZnO. A similar effect was observed for the case of the ZnO-PEDOT and PEDOT gratings. As seen in the Figure 6b, for PEDOT gratings, %T and Δ %T were 45% and 35% respectively; these values decreased to 36% and 27% for ZnO-PEDOT gratings. However, the diffraction efficiencies again showed significant increases: an average %DE and Δ %DE were 3.5% and 2.8% for PEDOT gratings, but increased significantly to 8.5% and 8.3% respectively as shown in Figure 6c.

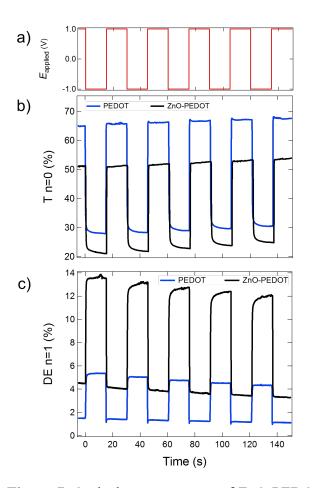


Figure 7. Optical measurements of ZnO-PEDOT and PEDOT gratings after a) applied potentials of -1.0 V and +1.0 V vs. Ag/AgCl showing the b) transmittance at the n = 0 spot and the c) diffraction efficiency at the n = 1 spot.

To understand these changes in the average %DE and Δ %DE, we need to consider the contributions to η and κ for the composite gratings. In the case of thin gratings, the diffraction efficiency *DE* is a linear combination of an absorptive component and a phase component (eqn (6)):^{15, 31, 44}

$$DE = a(\Delta \kappa)^2 + b(\Delta \eta)^2 \tag{6}$$

This equation can be used to explain the increases in the average %DE, but not the electrodiffractive component (Δ %DE). For the case of the composite ZnO-WO₃ and ZnO-

PEDOT gratings in this paper, an additional coupling between the ZnO and the absorptive WO₃ or PEDOT is observed, even though no electrodiffractive effect ($\Delta \kappa = \Delta \eta = 0$) is observed with ZnO gratings alone (optical measurements shown in Supporting Information Figure S4). Instead, the thicker ZnO overlayer exhibits "antenna-like" behavior and redirects the light into the electrochromic WO₃ or PEDOT component of the grating. This type of optical coupling occurs because the electrodeposited nanostructured ZnO coating is on the same scale as the light; similar optical effects have been previously observed in calculations of the diffraction efficiency of taller gratings.^{28, 44} Furthermore, the high surface area, nanostructured nature of the ZnO provides an additional coupling mechanism via the enhanced scattering of the incident light. It is the combination of the nanoscale structure and metamaterial patterning of the electrodeposited ZnO that creates enhanced electrodiffraction.

Conclusions

The enhanced absorption and electrodiffraction observed from the composite ZnO-WO₃ and ZnO-PEDOT gratings described in this paper clearly demonstrate that there is a strong optical coupling between the electrodeposited nanostructured ZnO overlayer and the electrochromic thin film layer underneath. This coupling has some significant implications; the presence of both nanoscale structuring and metamaterial patterning (e.g., gratings, nanocone arrays, or nanoring arrays) are both required for this coupling to occur. The electrodiffraction from these gratings increases in the presence of the high surface area nanostructured ZnO, even though the ZnO itself has no absorptive (κ) or electrochromic ($\Delta \kappa$) behavior. In these gratings, the ZnO acts as a type of "antenna" to deliver enhanced light to the underlying electrochromic materials. We have also observed this antenna coupling effect previously in the enhanced antireflectivity of PEDOT and gold nanocone arrays that were coated with electrodeposited ZnO nanostructures.³⁹ Going forward, we should be able to employ this coupling effect to enhance the production of electron-hole pairs by enhancing the optical absorption of TiO₂, In₂O₃, or Si semiconductor patterned gratings, nanocone arrays, or nanoring arrays.

Supporting Information

The following are available free of charge: (i) SEM images of WO₃ and PEDOT gratings, (ii) AFM measurements of ZnO-coated gratings, (iii) XPS of ZnO-coated gratings, and (iv) optical measurements for the transmission and diffraction efficiency of ZnO only gratings.

Notes

The authors declare no competing financial interests.

Acknowledgments

This work was supported by the National Science Foundation through grant CHE-1403506. SEM and XPS analyses were performed at the Irvine Materials Research Institute (IMRI) at UC Irvine. UV-Vis/NIR measurements were performed at the UC Irvine Laser Spectroscopy Labs. The authors would also like to thank the Penner Group for their help with AFM measurements.

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